

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: **10/660,833** Examiner: **Juan D. Valentin**
Inventor: **Shean-Jen Chen, Chun-Yu Lin, Fan-Ching Chien, K. T. Huang,**
W. P. Hu, Wen-Yih Chen, Kuan-Ching Lee and Wen-Hsien Li
Filing Date: **09/12/2003** Art Unit: **2877**
Title: **Surface Plasmon Resonance Sensor With High Sensitivity**

February 22, 2008

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO FINAL OFFICE ACTION

In response to the Office Action mailed **11/20/2007**, applicants respectfully **request continued examination** of the above-identified application. The following remarks which begin on page 2 of this paper are submitted for examiner's reconsideration and examination of the application. A Petition for Extension of Time along with the required fee is also submitted.